

## *Imaging and Imaging Detectors*



### Introduction

Detectors we have dealt with so far: **non-imaging detectors**.

This lecture: **imaging optical photons and X-rays**

Any imaging system has two parts:

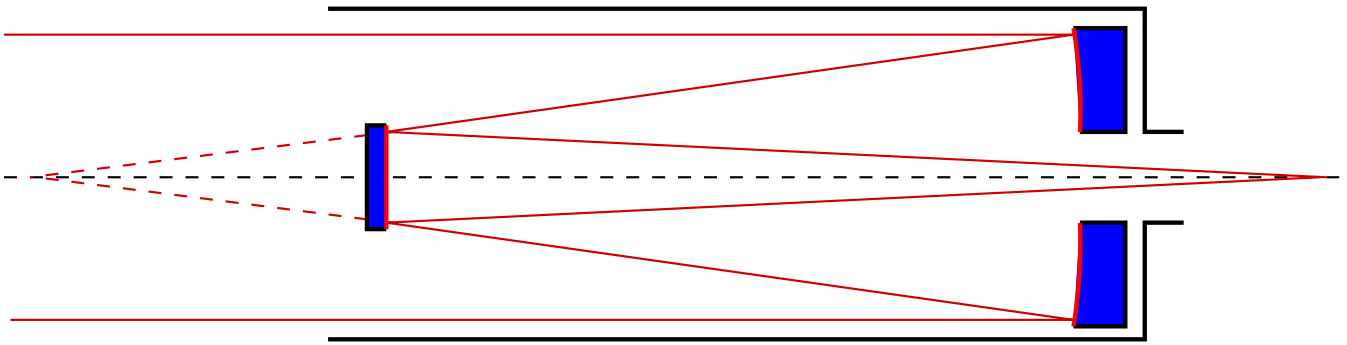
1. **Imaging optics**

In most applications, **mirrors** are used for imaging, although other techniques (variants of shadow cameras) are used, e.g., for  $\gamma$ -rays

2. **Spatially resolved detector**

i.e., a detector capable of measuring where a photon hits it in the focal plane. This can be a photographic plate or film, but is normally a **charge coupled device (CCD)**.

## Optical Imaging, I



Cassegrain telescope, after Wikipedia

*Reminder:* Optical telescopes are usually reflectors:

primary mirror → secondary mirror → detector

Main characteristics of a telescope:

- collecting area (i.e., open area of telescope,  $\sim \pi d^2/4$ , where  $d$ : telescope diameter)
- for small telescopes: angular resolution,

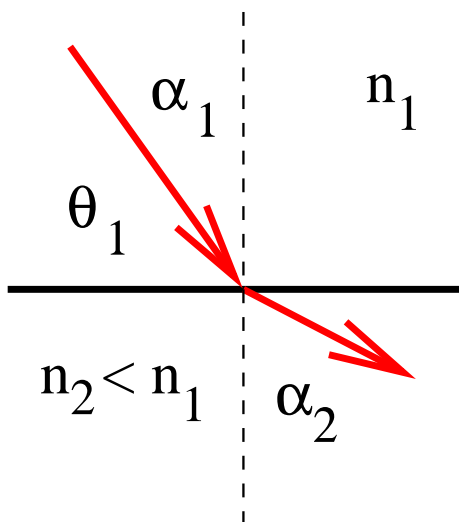
$$\theta = 1.22 \frac{\lambda}{d} \quad (4.1)$$

but do not forget the seeing!

Imaging

## Optical Imaging, II

Optical telescopes are based on principle that reflection “just works” with metallic surfaces. For X-rays, things are more complicated. . .



**Snell's law** of refraction:

$$\frac{\sin \alpha_1}{\sin \alpha_2} = \frac{n_2}{n_1} = n \quad (4.2)$$

where  $n$  index of refraction, and  $\alpha_{1,2}$  angle wrt. surface normal. If  $n \gg 1$ : **Total internal reflection**

Total reflection occurs for  $\alpha_2 = 90^\circ$ , i.e. for

$$\sin \alpha_{1,c} = n \iff \cos \theta_c = n \quad (4.3)$$

with the critical angle  $\theta_c = \pi/2 - \alpha_{1,c}$ .

Clearly, total reflection is only possible for  $n < 1$

Light in glass at glass/air interface:  $n = 1/1.6 \implies \theta_c \sim 50^\circ \implies$  principle behind **optical fibers**.

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## Optical Imaging, III

X-rays: theory gives index of refraction vacuum versus material as

$$n = 1 - N_A \frac{Z}{A} \frac{r_e}{2\pi} \frac{\rho}{\lambda^2} =: 1 - \delta \quad (4.4)$$

$N_A$ : Avogadro's number,  $r_e = 2.8 \times 10^{-15}$  m,  $Z$ : atomic number,  $A$ : atomic weight ( $Z/A \sim 0.5$ ),  $\rho$ : density,  $\lambda$ : wavelength (X-rays:  $\lambda \sim 0.1-1$  nm).

Critical angle for X-ray reflection:

$$\cos \theta_c = 1 - \delta \quad (4.5)$$

Since  $\delta \ll 1$ , Taylor ( $\cos x \sim 1 - x^2/2$ ):

$$\theta_c = \sqrt{2\delta} = 56' \rho^{1/2} \frac{\lambda}{1 \text{ nm}} \quad (4.6)$$

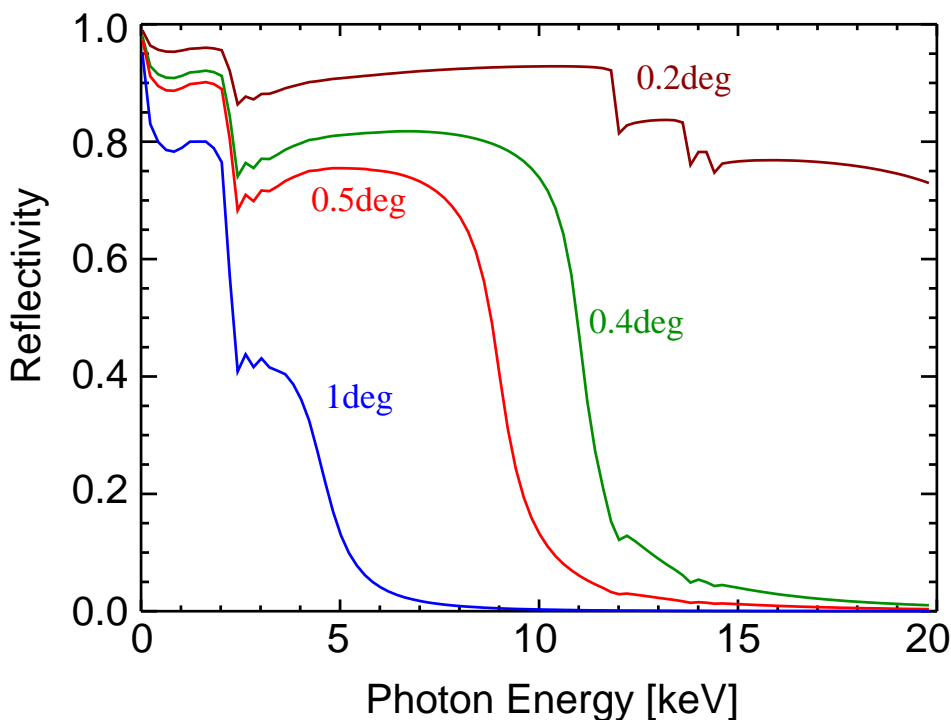
So for  $\lambda \sim 1$  nm:  $\theta_c \sim 1^\circ$ .

To increase  $\theta_c$ : need material with high  $\rho$

$\implies$  gold (XMM-Newton) or iridium (Chandra).

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## Optical Imaging, IV

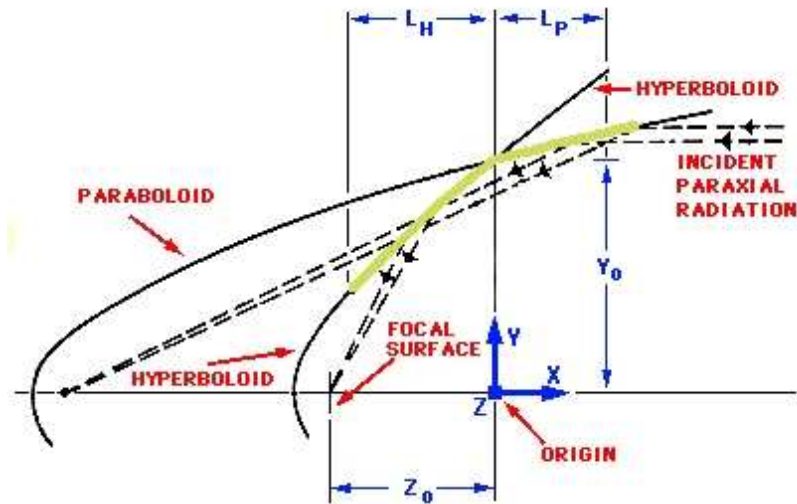


Reflectivity for Gold

X-rays: Total reflection only works in the soft X-rays and only under grazing incidence  $\implies$  grazing incidence optics.

Imaging

## Wolter Telescopes, I



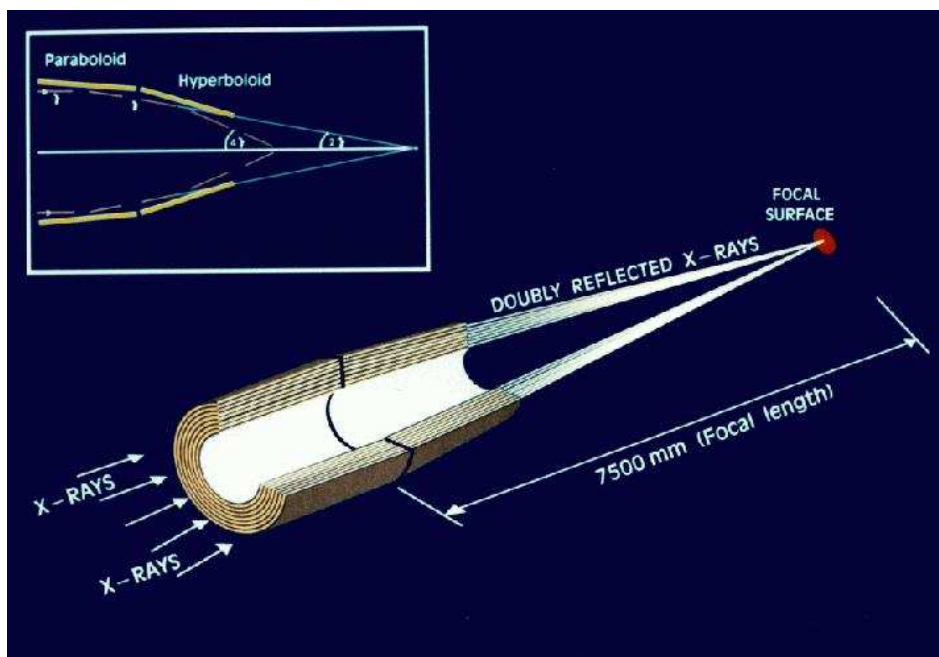
To obtain manageable focal lengths ( $\sim 10$  m), do imaging with telescope using **two reflections** on a parabolic and a hyperboloidal mirror

(Wolter, 1952, for X-ray microscopes, Giacconi, 1961, for UV- and X-rays).

But: **small collecting area** ( $A \sim \pi r^2 l / f$  where  $f$ : focal length)

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## Wolter Telescopes, II

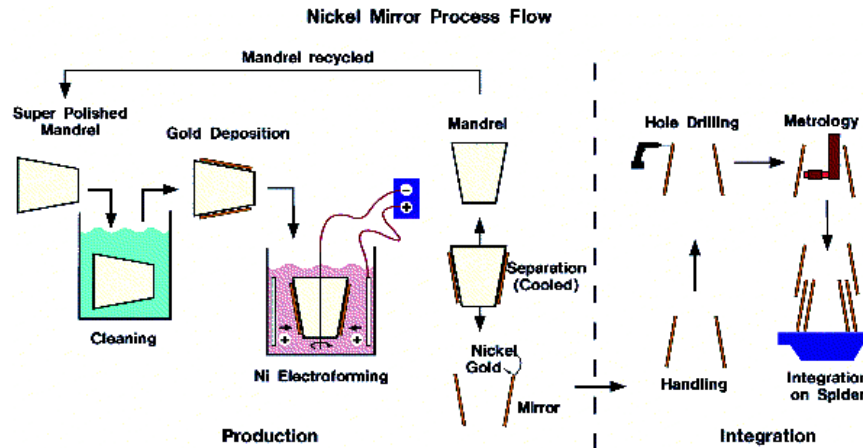


ESA/XMM

Solution to small collecting area: **nested mirrors**

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## Mirror manufacture, I



*Recipe for making an X-ray mirror:*

1. Produce mirror negative ("Mandrels"): Al coated with Kanigen nickel (Ni+10% phosphorus), super-polished [0.4 nm roughness].
2. Deposit 250 nm Au onto Mandrel
3. Deposit 1 mm Ni onto mandrel ("electro-forming", 10  $\mu\text{m}/\text{h}$ )
4. Cool Mandrel with liquid N. Au sticks to Nickel
5. Verify mirror on optical bench.

Total production time of one mirror: 12 d, for XMM: 3 $\times$ 58 mirrors.

Imaging

## Mirror manufacture, II



Gold plastered mandrel for one of the XMM mirrors before electroforming the Ni shell onto the gold.

ESA picture 96.05.006-070

Imaging

## Mirror manufacture, III



... insertion of Mandrel into electroforming bath

ESA picture 96.12.002-016

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## Mirror manufacture, IV

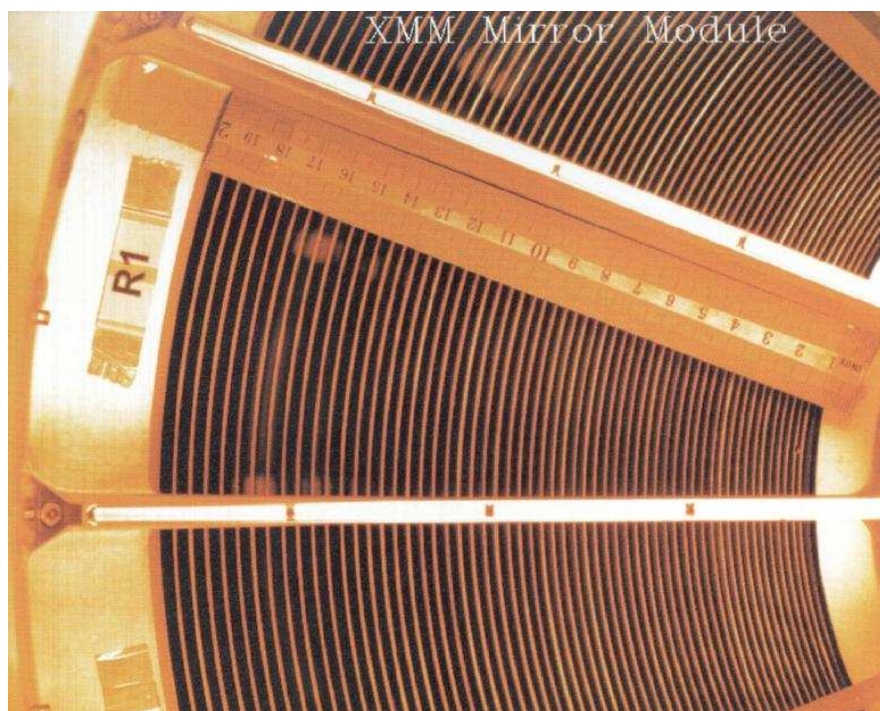


... and the mirror is done

ESA picture 96.12.002-093

Imaging

## XMM-Newton



Top of the XMM mirrors:  
3 mirror sets, each consisting of 58 mirrors,

- Thickness between 0.47 and 1.07 mm
- Diameter between 306 and 700 mm,
- Masses between 2.35 and 12.30 kg,
- Mirror-Height 600 mm
- Reflecting material: 250 nm Au.

photo: Kayser-Threde

Imaging

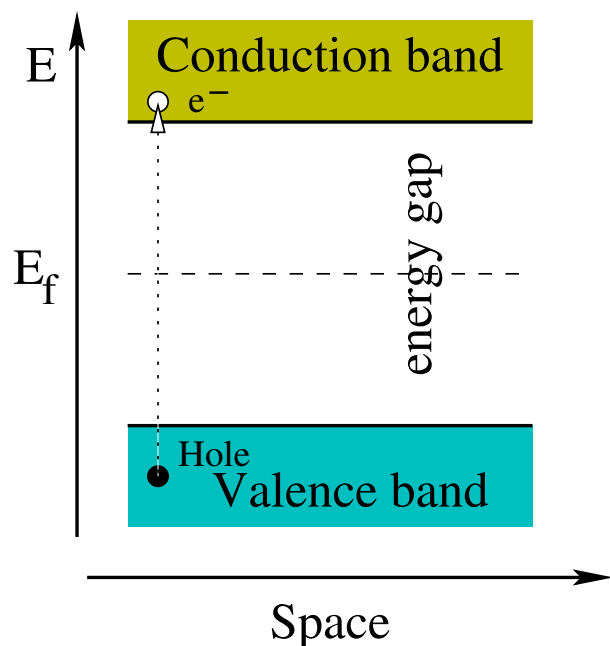
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11



The XMM-Newton Spacecraft (photo: ESA)

## Reminder: Semi-Conductors, I



Semiconductors: separation of **valence band** and **conduction band**  
 $\sim 1$  eV (=energy of visible light).

Absorption of photon in Si: Energy of photon released

Number of electron-hole pairs produced:

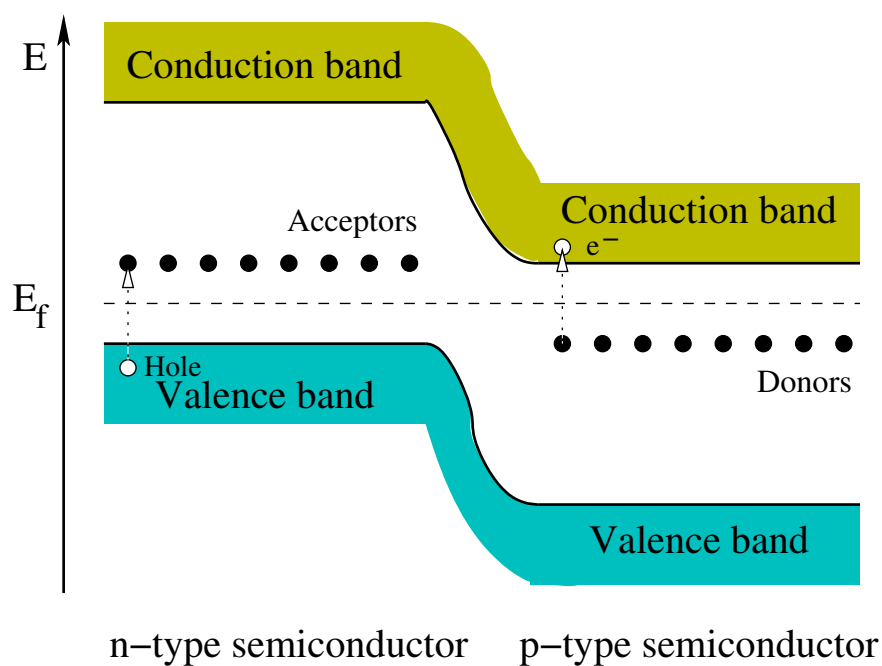
$$N \sim \frac{h\nu}{E_{\text{gap}}} \quad (4.7)$$

in other words:

- optical light:  $\sim 1$  electron-hole pair
- X-rays (keV):  $\sim 1000$  electron-hole pairs

*Problem:* electron-hole pairs recombine immediately in a normal semiconductor.

## Reminder: Semi-Conductors, II



“Doping” the semiconductor moves the valence- and conduction bands.

Connecting a “n-type” and a “p-type” semiconductor gives a **pn-junction**.

Electron-hole pairs created at pn-junction will be separated by field gradient

$\Rightarrow$  electrons can then be collected in potential well away from the junction and read out.



## Reminder: Semi-Conductors, III

Number of electron-hole pairs produced determined by band gap + “dirt effects”

(“dirt effects”: e.g., energy loss going into bulk motion of the detector crystal [“phonons”])

Material	$Z$	Band gap (eV)	$E/\text{pair}$ (eV)
Si	14	1.12	3.61
Ge	32	0.74	2.98
CdTe	48–52	1.47	4.43
Hgl2	80–53	2.13	6.5
GaAs	31–33	1.43	5.2

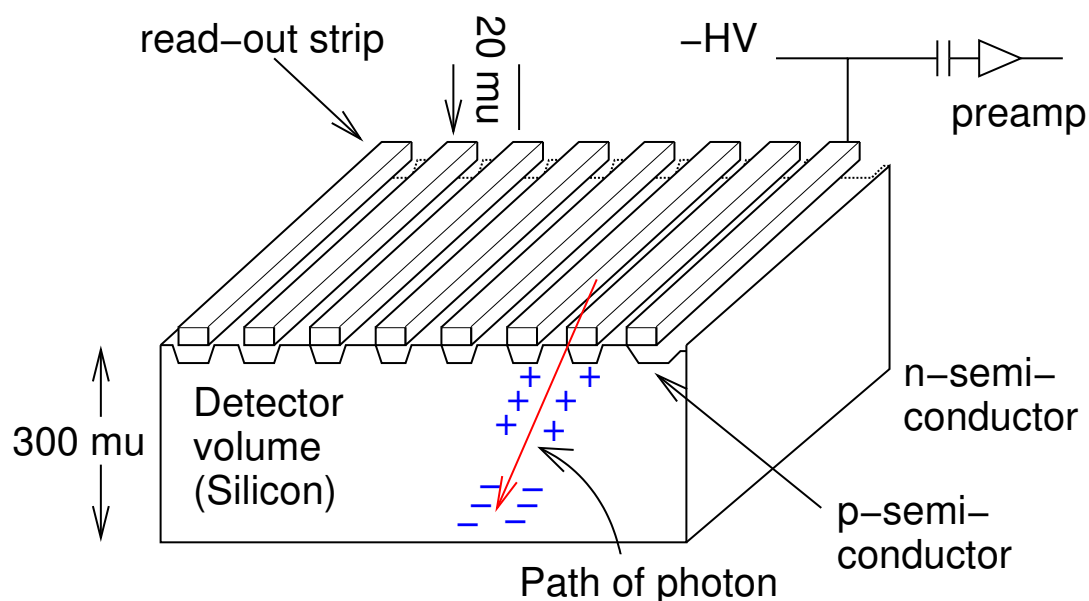
(so  $\sim 1$  electron for optical photons,  $\sim 1000$  electrons for X-rays)

Since band gap small: thermal noise  $\implies$  need cooling

(ground based: liquid nitrogen,  $-200^\circ\text{C}$ , in space: cryostats)

## Charge Coupled Devices

## Strip Detectors



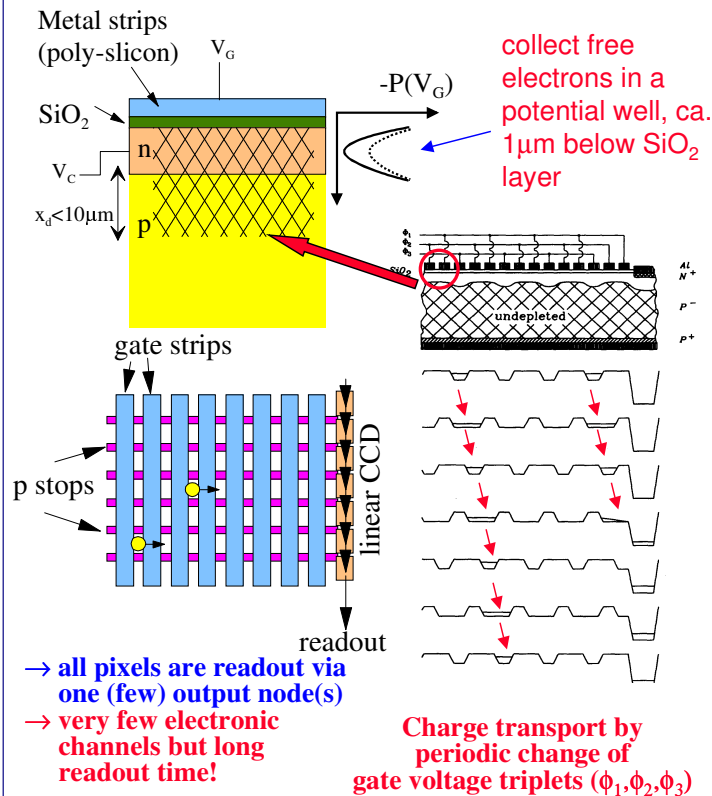
after Grupen

First attempt at spatial resolution obtained by segmenting the p-doped layer:  
microstrip detectors

## Charge Coupled Devices

## ◆ Charge Coupled Devices (CCD)

### MOS structure with segmented metal layer


 CERN Academic Training 97/98  
Particle Detectors

Christian Joram

II/39

4-20

## CCDs, II

optical CCDs: measure **intensity**  $\implies$  need *long* exposures

X-ray CCDs: measure **individual photons**  $\implies$  need fast readout

bright sources: several 1000 photons per second  $\implies$  readout in  $\mu\text{s}$ !

In X-rays: **spectroscopy possible**. Typical resolution reached today:

$$\frac{\Delta E}{E} = 2.355 \sqrt{\frac{F}{3.65E}} \quad (4.8)$$

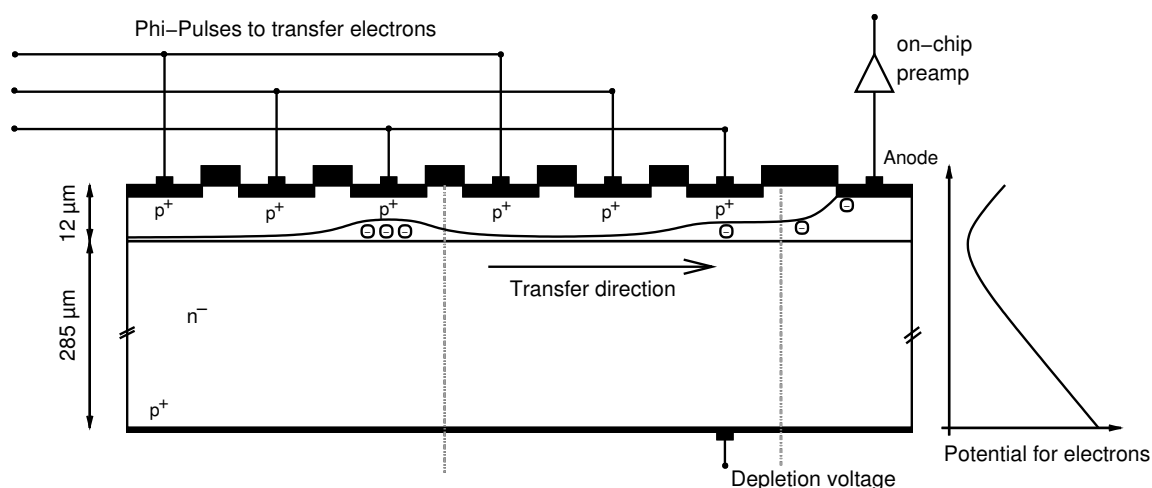
with  $F \sim 0.1 \implies \sim 0.4\%$ , so much better than proportional counters.

(but same  $\Delta E/E \propto E^{-1/2}$  proportionality because of Poisson!)

For both optical and X-rays: **sensitivity close to 100%**

Si based CCDs are currently the best available imaging photon detectors for optical and X-ray applications.

## CCDs, III



Schematic structure of the *XMM-Newton* EPIC pn CCD.

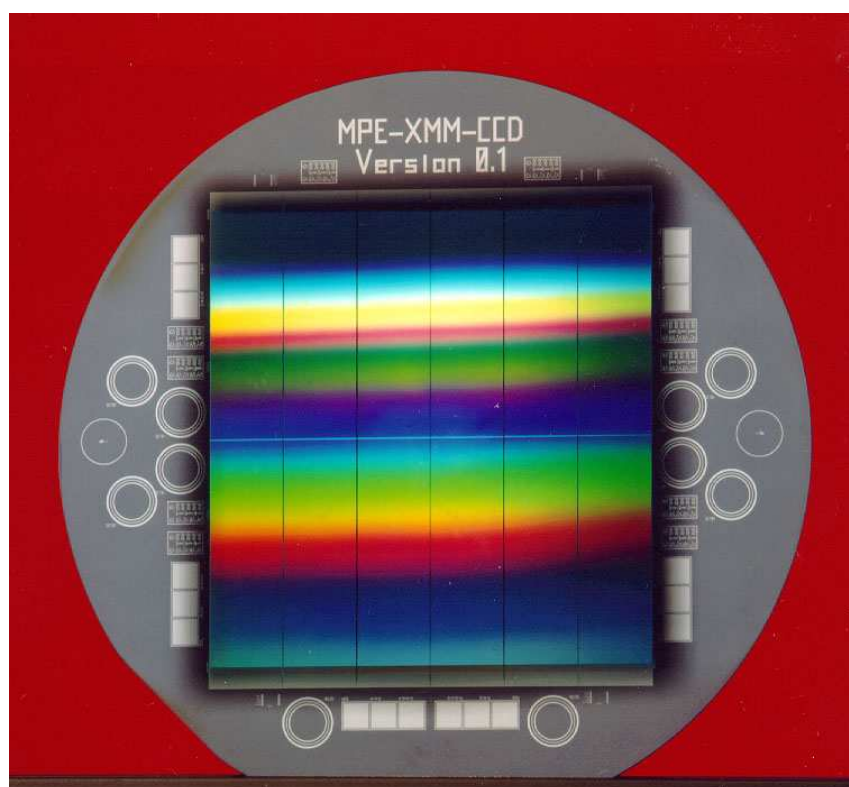
**Problem:** Infalling structure has to pass *through* structure on CCD surface  $\Rightarrow$  loss of low energy response, also danger through destruction of CCD structure by cosmic rays. . .

**Solution:** Irradiate the back side of the chip. Deplete whole CCD-volume, transport electrons to pixels via adequate electric field ("**backside illuminated CCDs**")

**Note:** solution works mainly for X-rays

## Charge Coupled Devices

## XMM-Newton: EPIC-pn CCD

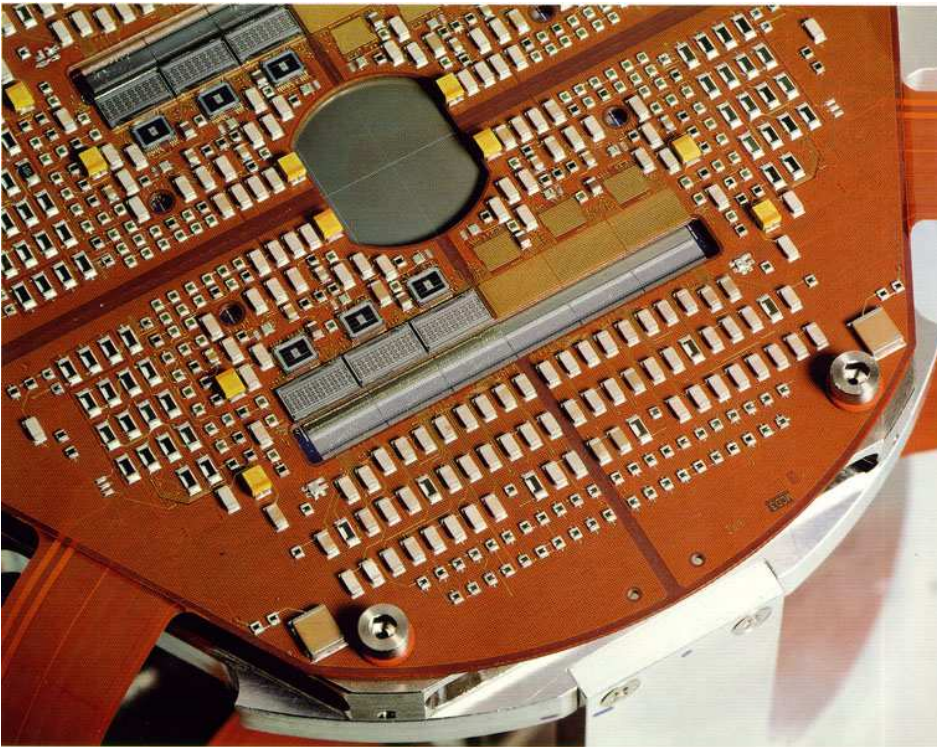


*XMM-Newton*: Array of individual backside illuminated CCDs on one Silicon wafer  $\Rightarrow$  requires extreme care during production

at the time of production one of the most complex Silicon structures ever made (diameter: 65.5 mm)

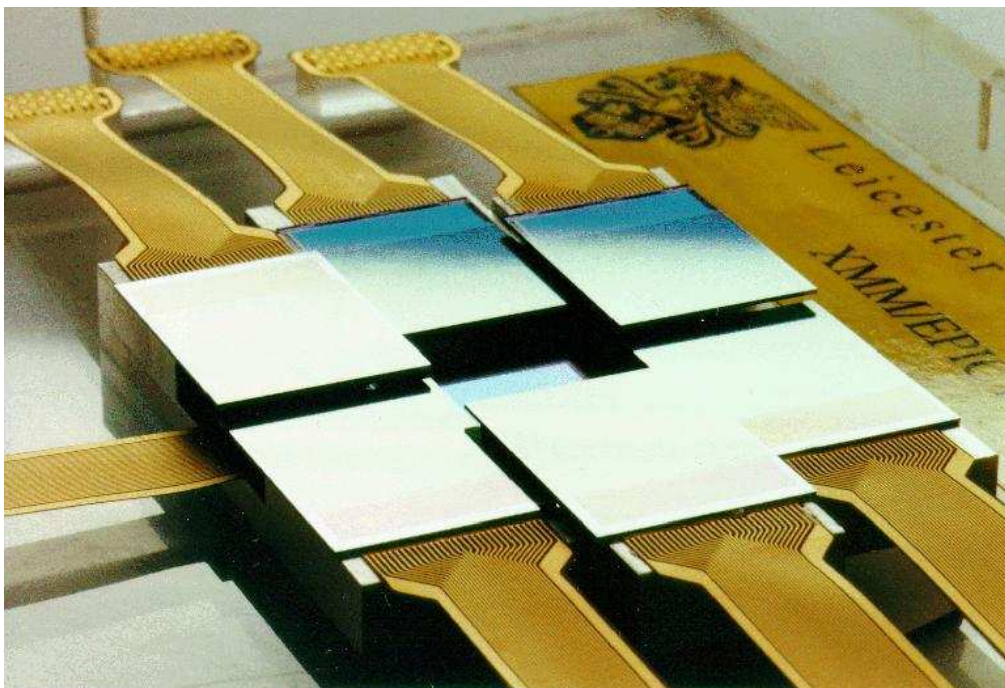
## Charge Coupled Devices

## XMM-Newton: EPIC-pn CCD



Backside of the EPIC-pn camera head

## XMM-Newton: EPIC-pn CCD



*XMM-Newton* (EPIC-MOS; Leicester): 7 single CCDs with  $600 \times 600$  pixels, mounting is adapted to curved focal plane of the Wolter telescope.